

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination 09/683,857 CHEN ET AL.	
		Examiner David L. Hogans	Art Unit 2813	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-5,242,841	09-1993	Smayling et al.	438/275
B	US-5,519,247	05-1996	Arbus et al.	257/437
C	US-6,444,487	09-2002	Boggs et al.	438/48
D	US-6,130,458	10-2000	Takagi et al.	257/351
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J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
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S					
T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages
	U	Quirk et al., Semiconductor Manufacturing Technology (2001), Prentice Hall, pages 228, 229 and 348
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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